

ALL PATENTS, INCLUDING DESIGN For Application Based on PCT: Paris Convention or Non Priority

Attorneys' Docket No. A-20929

As a below named inventor, I declare that my residence, post office address and citizenship are stated below next to my nam, that the information given herein is true, that I believe that I am the original, first and sol inventor (if only one name is listed below), or an original, first and joint inventor (if plural inventors are named below, or on additional sheets attached hereto) of the subject matter which is claimed and for which patent is sought on the invention entitled: In Situ Proximity GAP Monitor for Lithography, which is described and claimed in the application attached hereto.

I hereby state that I have reviewed and understand the contents of the above-identified specification, including the claims, as amended by any amendment referred to above.

I acknowledge the duty to disclose information which is material to patentability as defined in Title 37, Code of Federal Regulations, §1.56.

I hereby claim foreign priority benefits under Title 35, United States Code, §119 of any foreign application(s) for patent or inventor's certificate listed below and have also identified below any foreign application for patent or inventor's certificate having a filing date before that of the application on which priority is claimed.

Prior Foreign Application(s):				Priority Claimed	
	(Number)	(Country)	(Day/Mo/Year)	None	
I hereby claim the ben	efit under Title 35, United 60/155,571	States Code, §119(e) of any L	United States provisional applicat September 24, 1999	ion(s) listed below.	
	(Provisional Appln.Se	er.No.)	(Filing Date)	_	
on PCT international a information which is m prior application and th	pplication in the manner p aterial to patentability as d	States Code, §120 of any Unit subject matter of each of the or orovided by the first paragraph efined in Title 37, Code of Fede tional filing date of this applicat	of Title 35, United States Code, eral Regulations, §1.56 which bed	PCT international application(s) designating closed in the prior United States application §112, I acknowledge the duty to disclose arne available between the filing date of the	
: =	n.Ser.No.)	(Filing Date)	(Status: patented, pend	ding, abandoned)	
POWER OF ATTORN 29,565, John P. Shanr No. 43,366; Cameron tigansact all business in direct all communication	IEY: As a named inventor non, Reg. No. 29 276; And H. Tousi, Reg. No. 43, 19 the Patent and Trademar ons to:	I hereby appoint as principal frew C. Aitken, Registration No 17: Patrick Hogan, Registration k Office connected with this ap	attorneys Richard L. Aitken, Reg 36 799: Laurence J. Marnoefer No. 29 543 and Paul Bernkopf plication and any related United S	No. 18,791: Clifton E. McCann, Reg. No. Reg. No. 21,091: Raiph P. Albrecht, Reg. Registration No. 41,615, to prosecute and tates and international applications. Please	
		LANE, AITKEN & N Watergate Offi 2600 Virginia Avenu Washington, I Telephone: (20 Facsimile: (20	McCANN, L.L.P. ice Building s, N.W., Suite 901 J.C. 20037		
and further that these	statements were made with 1001 of Title 18 of the Un	th the knowledge that willful fal	se statements and the like so ma	nformation and belief are believed to be true; ide are punishable by fine or imprisonment, pardize the validity of the application or any	
Full name and signatu	ure of sole or first inventor	Alek C. CHEN	Che	Feb. 2, 2000 Date	
Residenc : Mount Kis	sco. New York				

Country of Citizenship: U.S.

cg

Post Office Address: 38 Ridge Road, Mount Kisco, NY 10549